## **EUROPEAN PATENT OFFICE**

## **Patent Abstracts of Japan**

PUBLICATION NUMBER

09132661

**PUBLICATION DATE** 

20-05-97

APPLICATION DATE

08-11-95

APPLICATION NUMBER

07289442

APPLICANT: HITACHI CHEM CO LTD;

INVENTOR: MIKAMI YOSHIKATSU;

INT.CL.

C08J 9/06 // C08L 23:02

TITLE

PRODUCTION OF FOAM FOR CMP PAD

ABSTRACT: PROBLEM TO BE SOLVED: To obtain a foam used for a CMP pad and having excellent water resistance and consequent durability by forming a mixture comprising a crosslinking agent, a heat-decomposable blowing agent and a polyolefin resin containing an abrasive into a sheet and crosslinking and foaming this sheet.

> SOLUTION: A crosslinking agent, a crosslinking aid (A), a heatdecomposable blowing agent (B), an abrasive (C) and a polyolefin resin (D) are melt-kneaded at the decomposition temperature of component B or below, and the resultant mixture is formed into a sheet, This sheet is crosslinked and foamed to form a foam for a CMP(chemical-mechanical polishing) pad. Examples of component D include polypropylene and polyethylene, An example of component A is tbutylcumyl peroxide. An example of component B is an organic type such as azodicarbonamide or an inorganic type such as sodium carbonate/citric acid mixture. The composition of a combination of component A with component B is desirably such that cell diameters of several tensum or below can be realized. Component C used is desirably a finely divided silicon oxide abrasive, This foam has excellent water resistance as compared with a conventional urethane foam, so that it can give a CMP pad having durability.

COPYRIGHT: (C)1997,JPO

THIS PAGE BLANK (USPTO)